

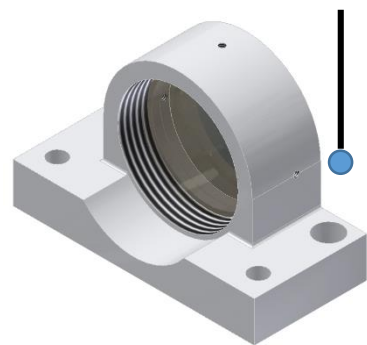
Mechanical metrology for alignment @OABr

1. Concept
2. Available facilities and expertise at OABr
3. Examples of use

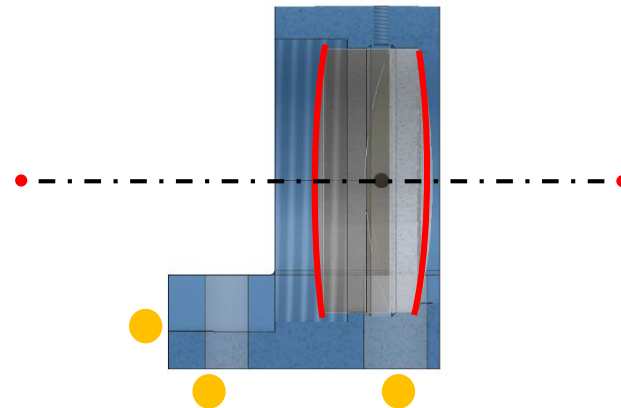
Concept

New approach based onto **dimensional characterization** of optical/optomechanical elements and semi-kinematic **interface adjustment**

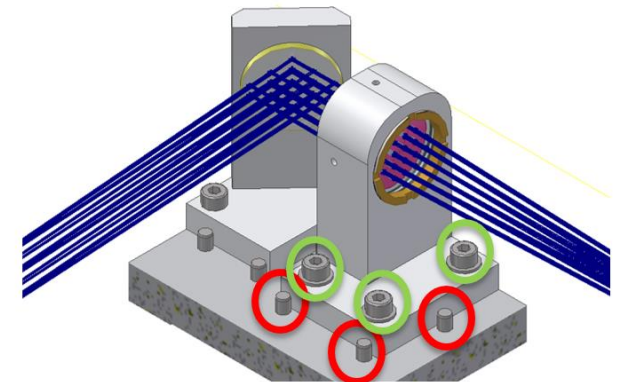
- Characterize the optical elements by means of non optical metrologies
- Characterize the optomechanical mounts
- Reference the optical surfaces vs. mechanical data
- Position the optomechanics in space
- Evaluate the stability in time



measure



reference



align

Facilities

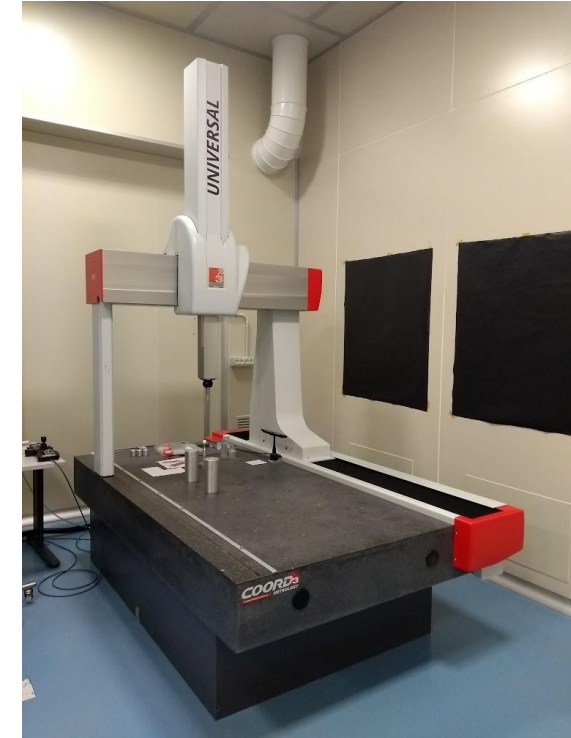
- Articulated arm

- 7 DoFs system
- Contact measurement, manual
- Volumetric accuracy = +/-0.041 mm



- Coordinate measuring machine (CMM)

- Cartesian reference system
- Contact measurement
- MPE = 1.8 μm + 3 $\mu\text{m}/\text{m}$

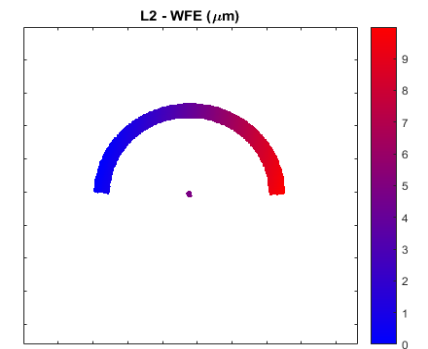
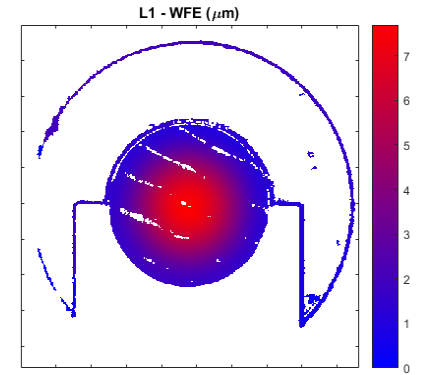
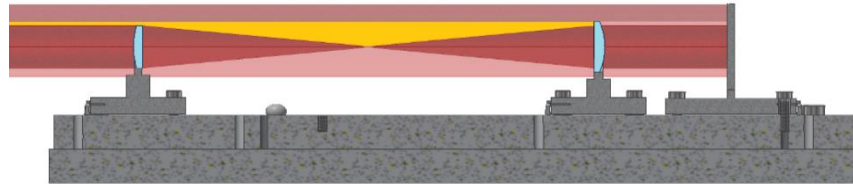
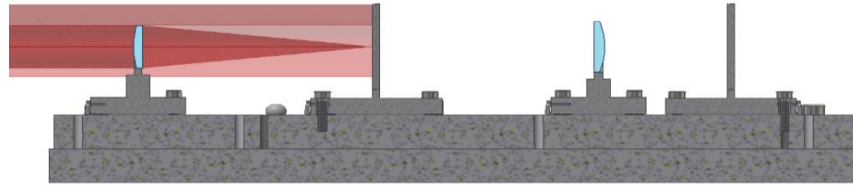


- Laser tracker (LT)

- Spherical reference system (alt-azimuth)
- Time of flight radial distance measurement
- MPE = 16 μm + 0.8 $\mu\text{m}/\text{m}$ (linear)
20 μm + 5 $\mu\text{m}/\text{m}$ (radial)

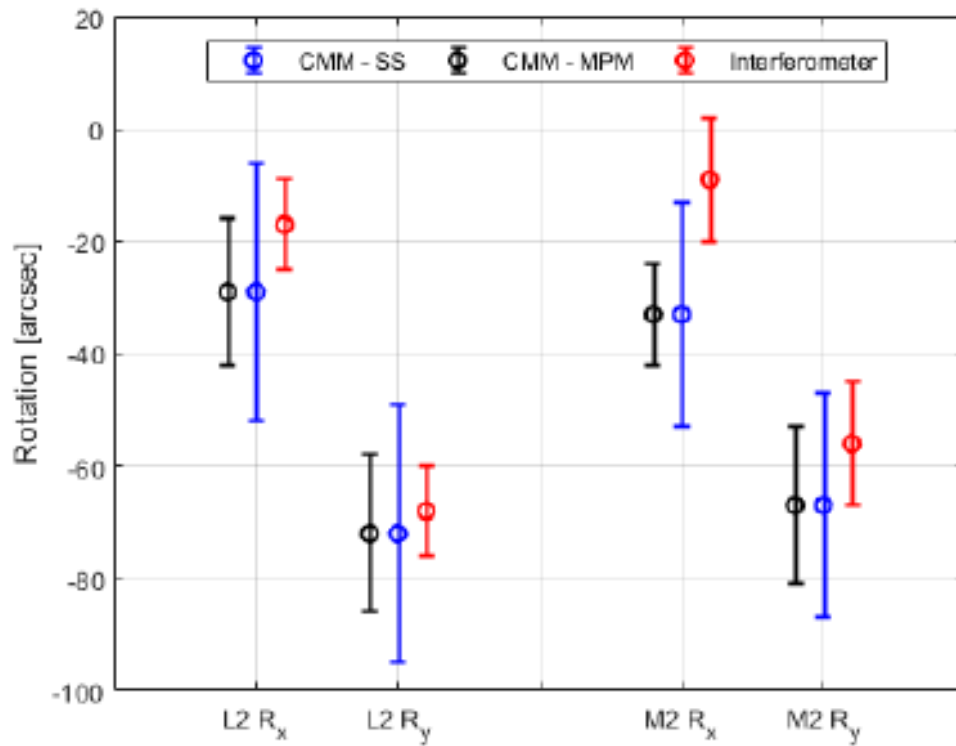


Verification: CMM vs. interferometer

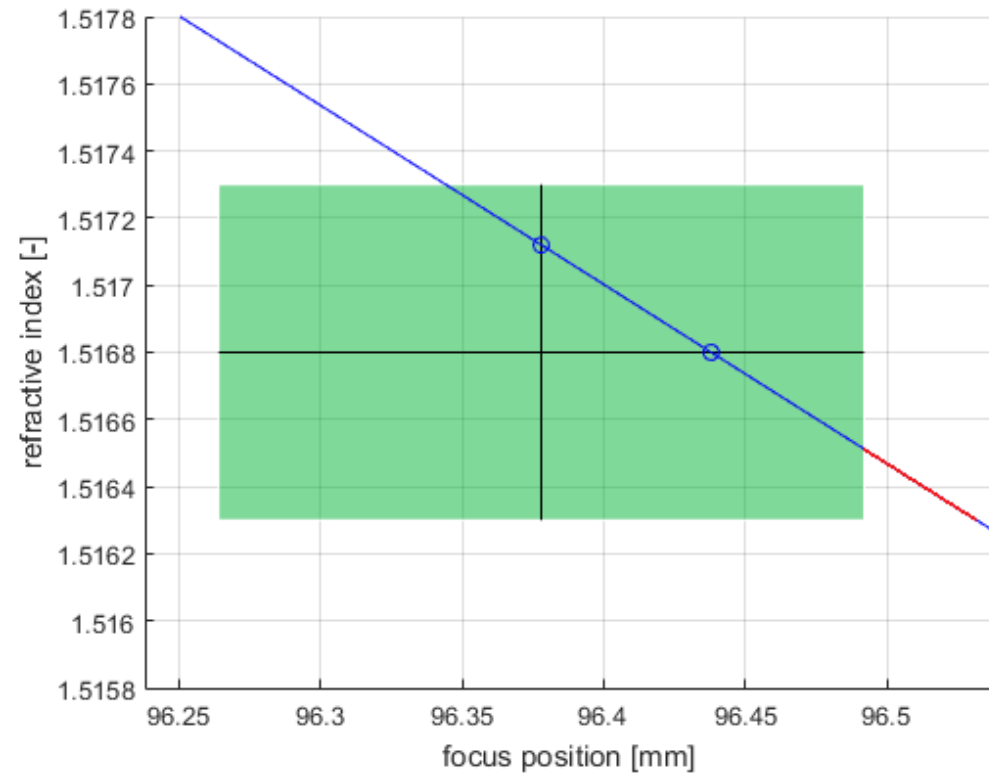


Verification: CMM vs. interferometer

Tip-tilt

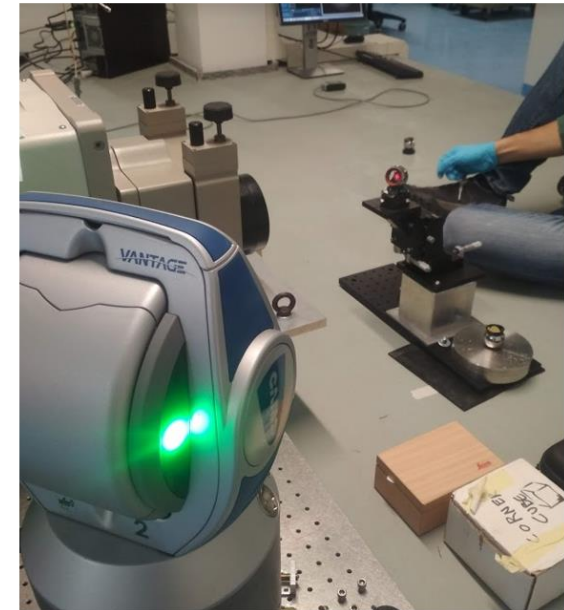
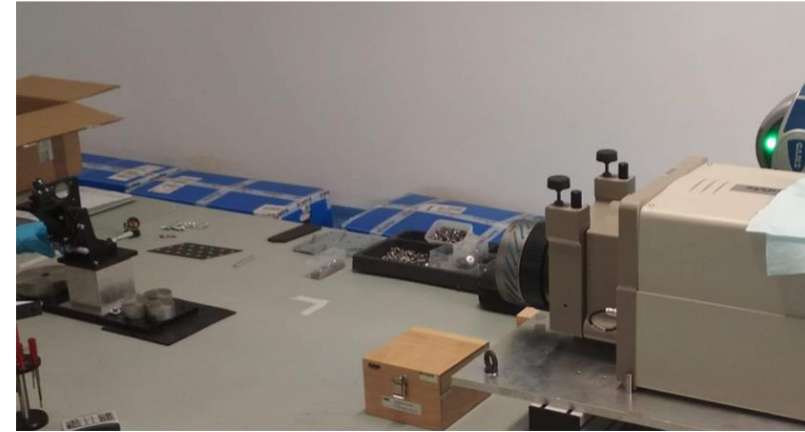
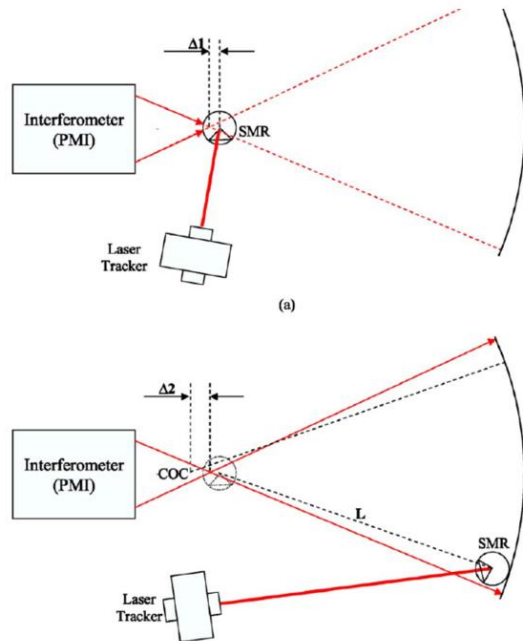


Focus



Example: LT + Interferometer

Measure of the RoC of a low F/# sphere



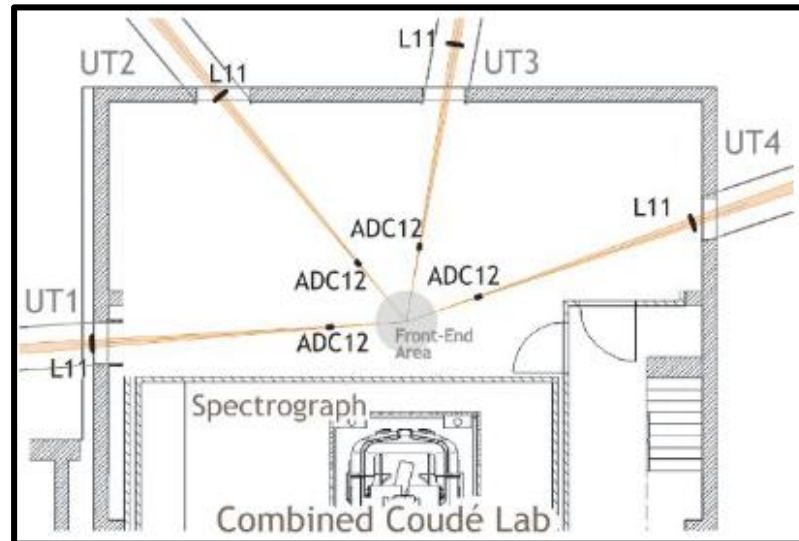
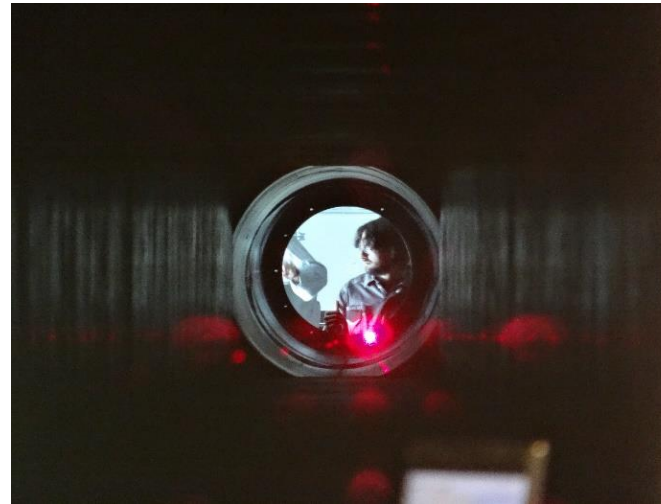
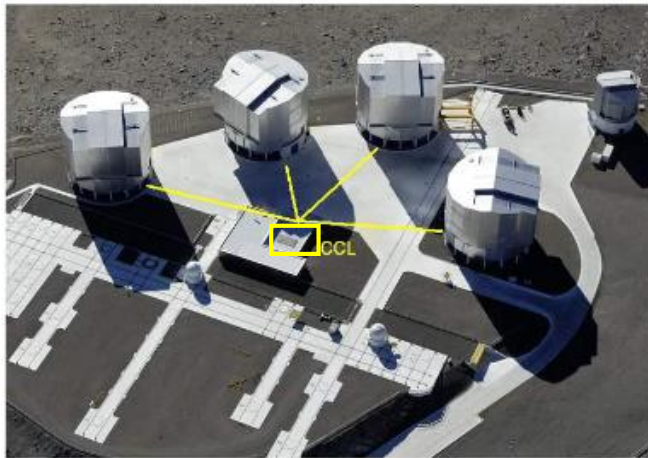
Radius with spherometer: 4921.0 ± 0.5 mm

Radius with LT+Interferometer: 4921.094 ± 0.014 mm

Large systems

Infrastructures

- VLT - Coudé tunnels
- VLT - Coudé room



Large systems

Meter size instruments

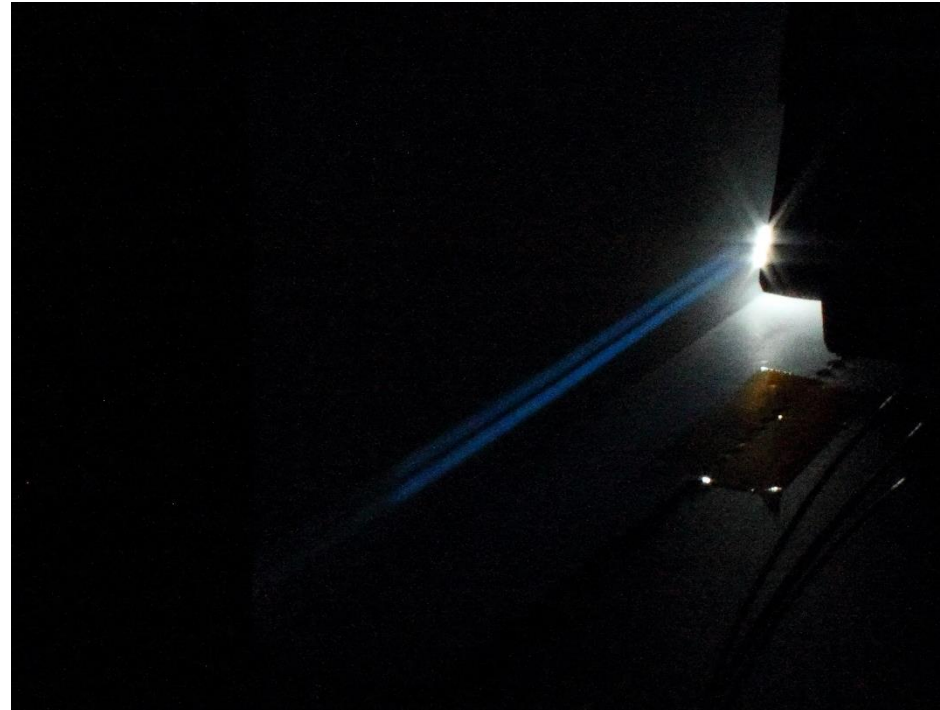
- VLT - ESPRESSO Spectrograph: active alignment with optical metrology



Large systems

Meter size instruments

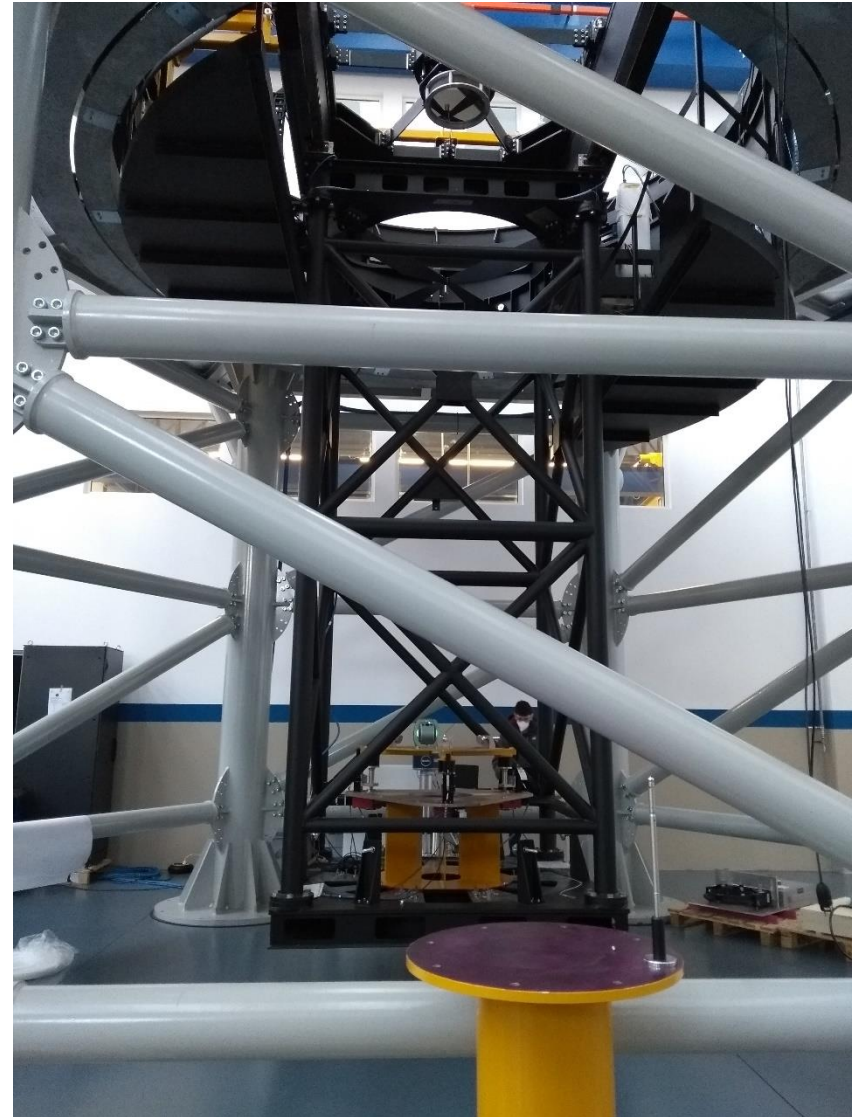
- VLT - ESPRESSO Spectrograph: autocollimation test



Large systems

Meter size mirrors

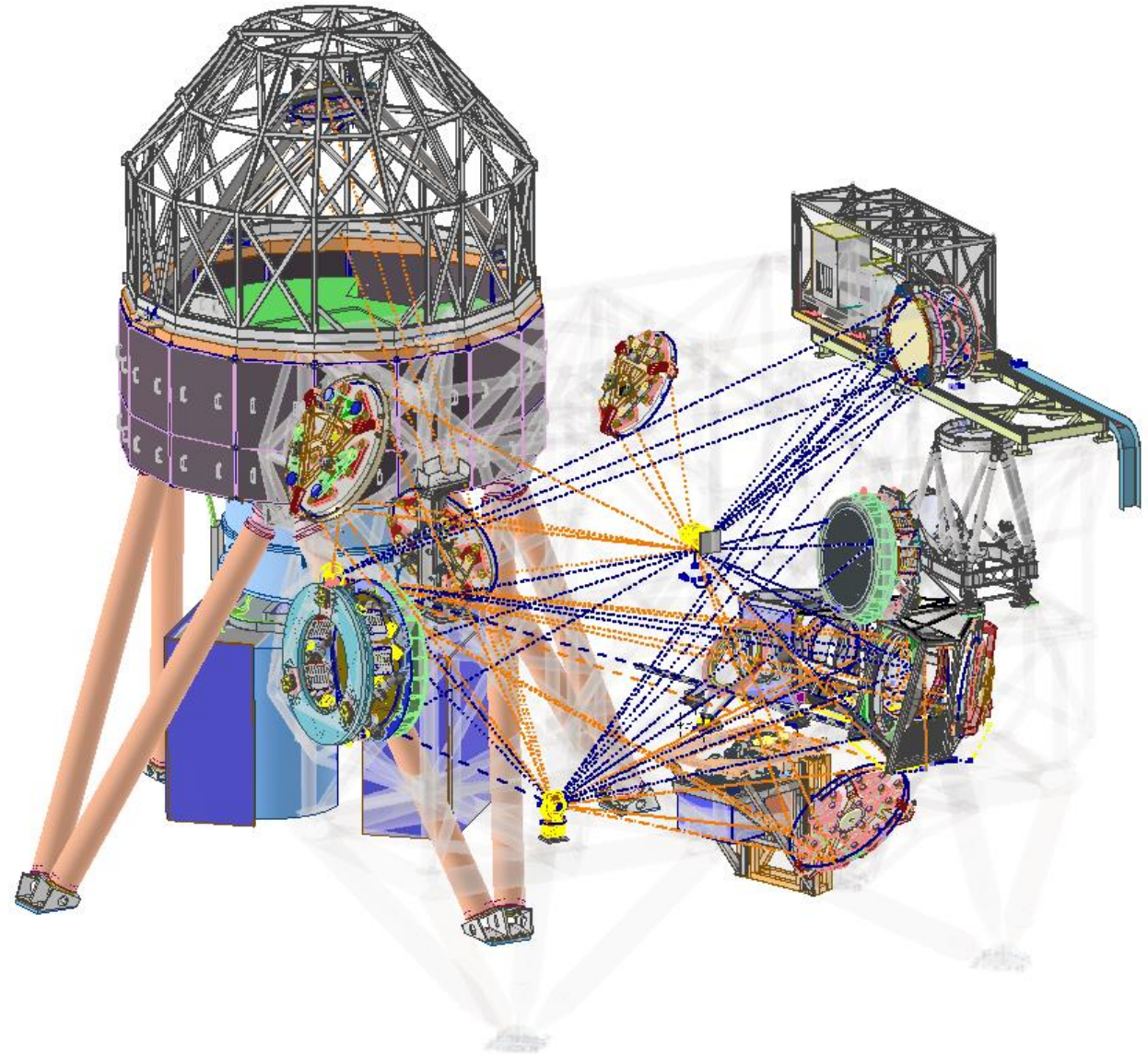
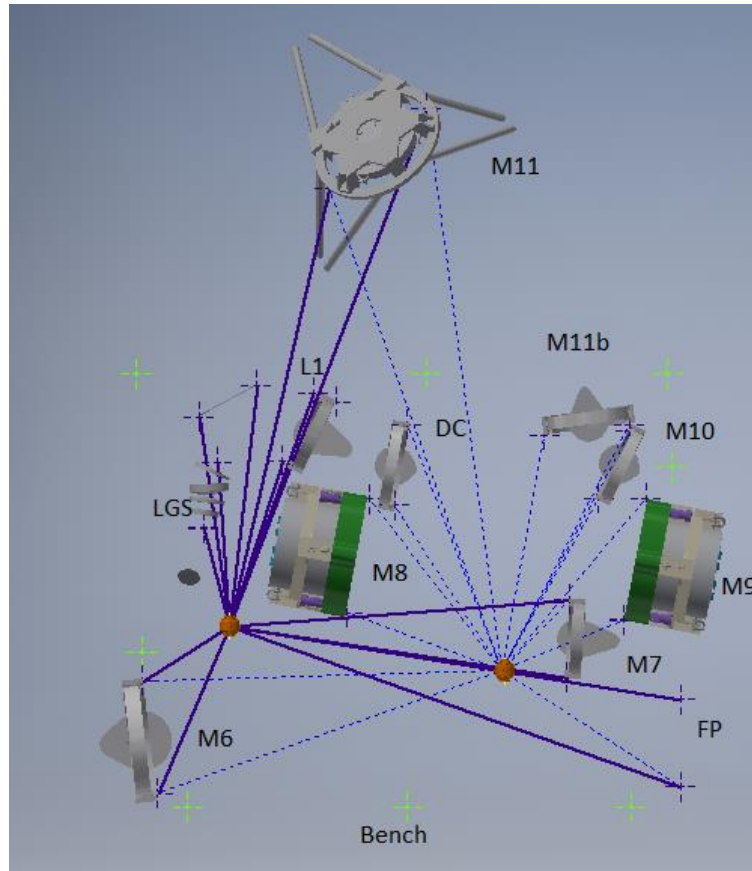
- ELT - M4-OTT alignment



Large systems

Meter size instruments

- ELT - MAORY



Small systems

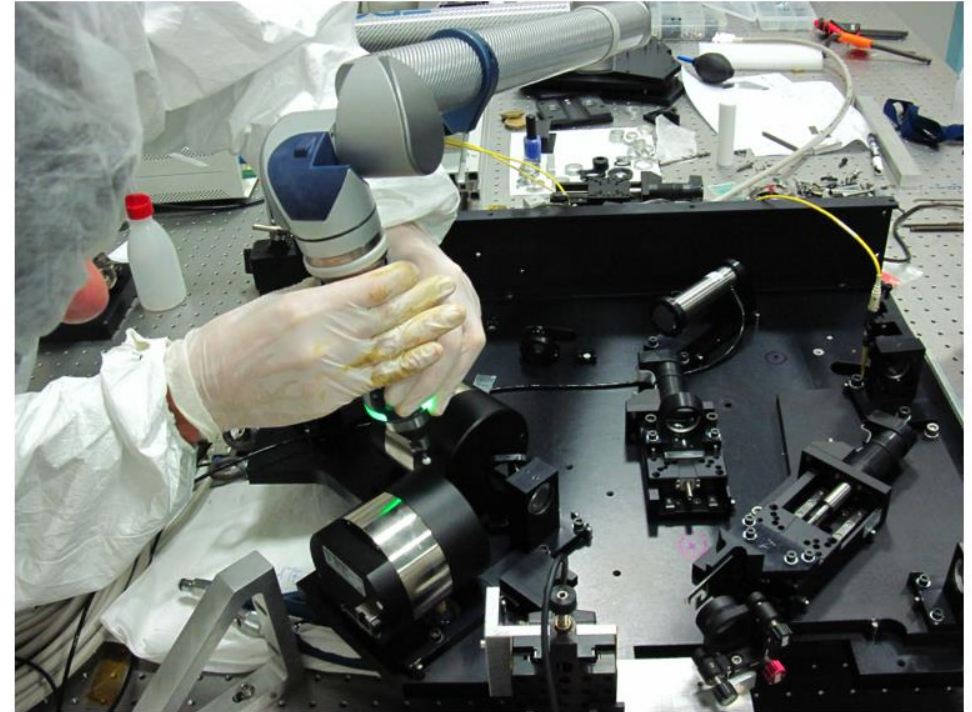
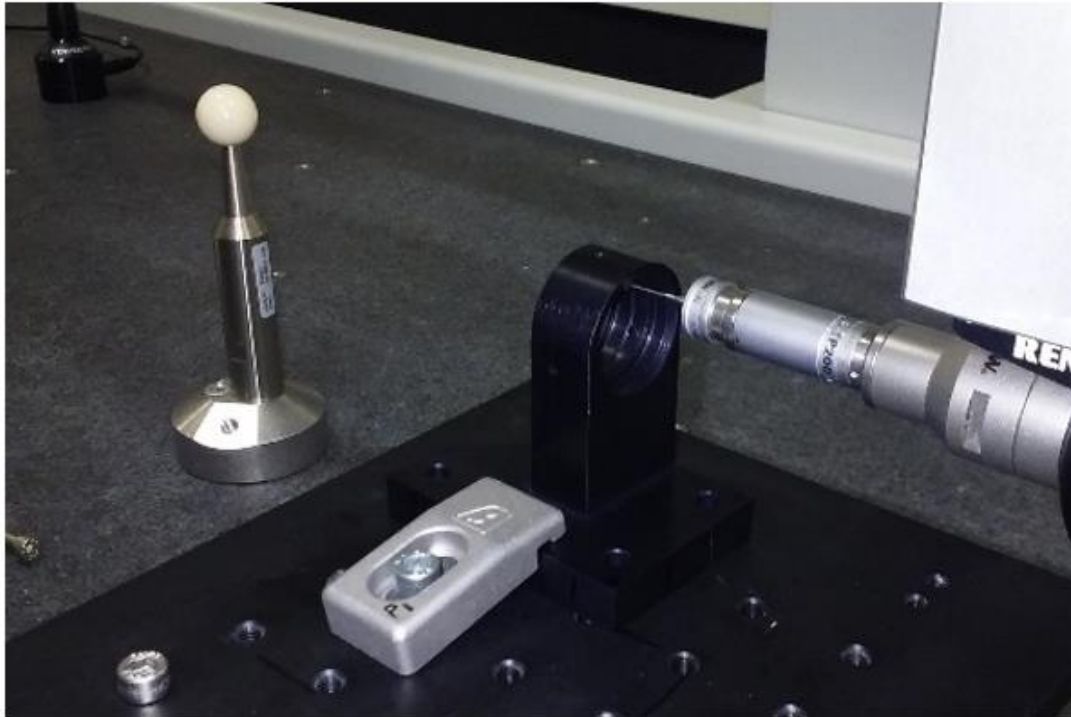
Every element mechanically characterized and 6 reference points are acquired (CMM).



Optical elements glued into the mounts

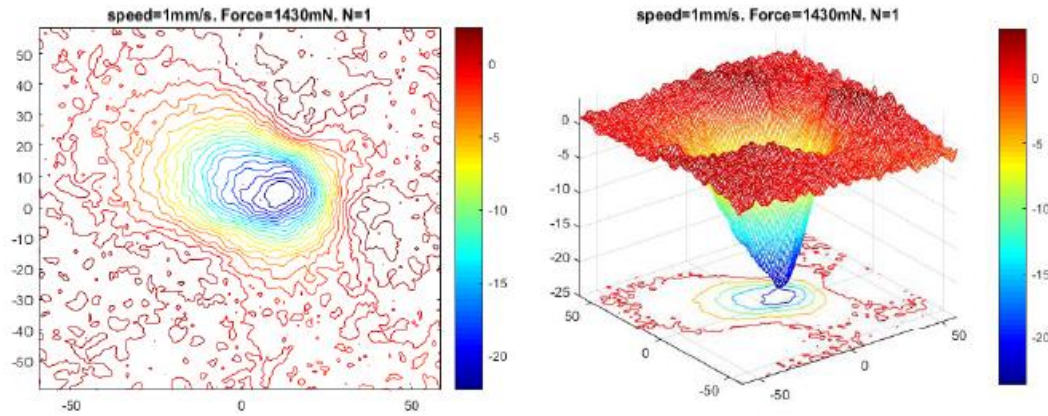


Elements aligned using the 6 reference points (AACMM)

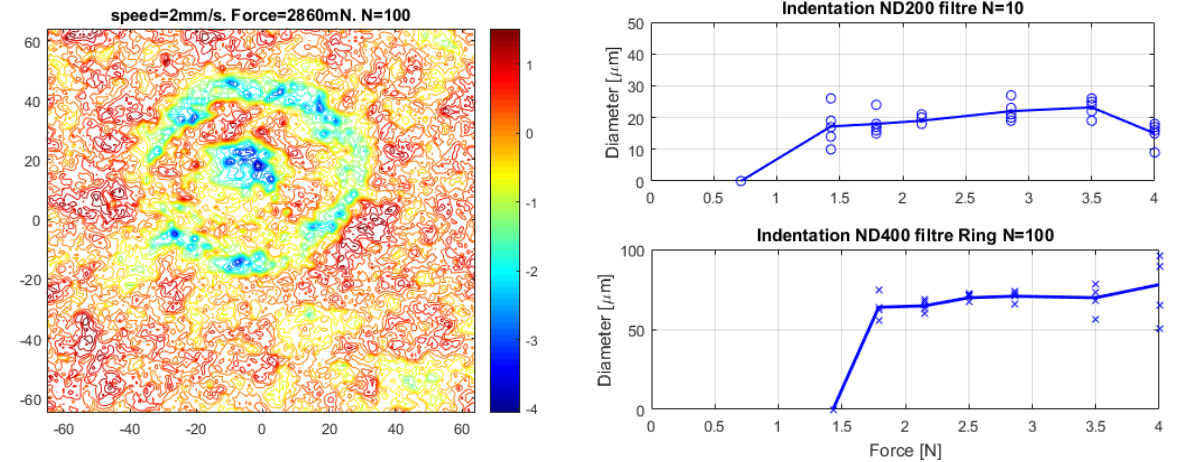


CMM contact damage

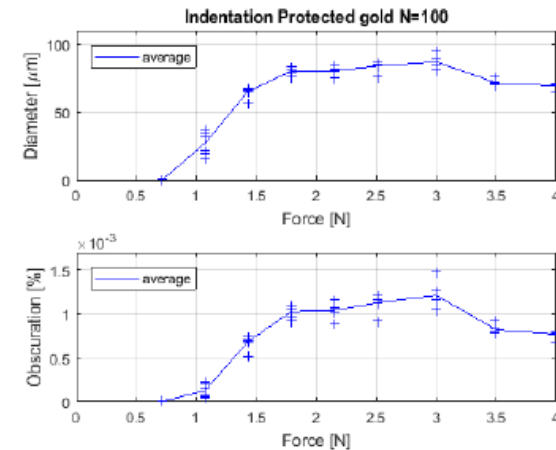
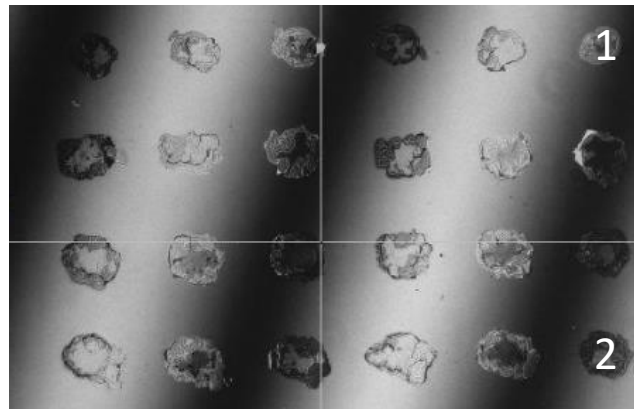
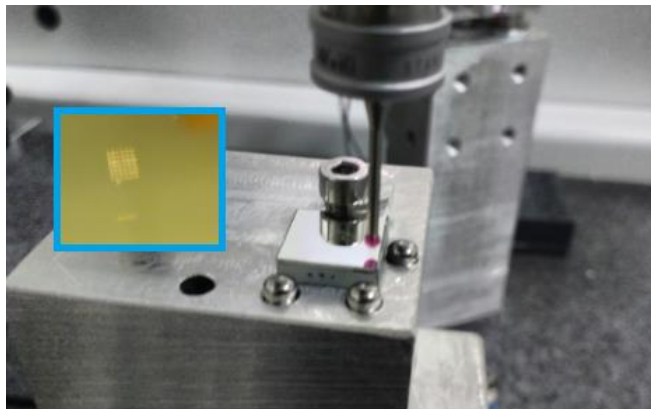
CaF₂ – uncoated



Inconel coating on borosilicate

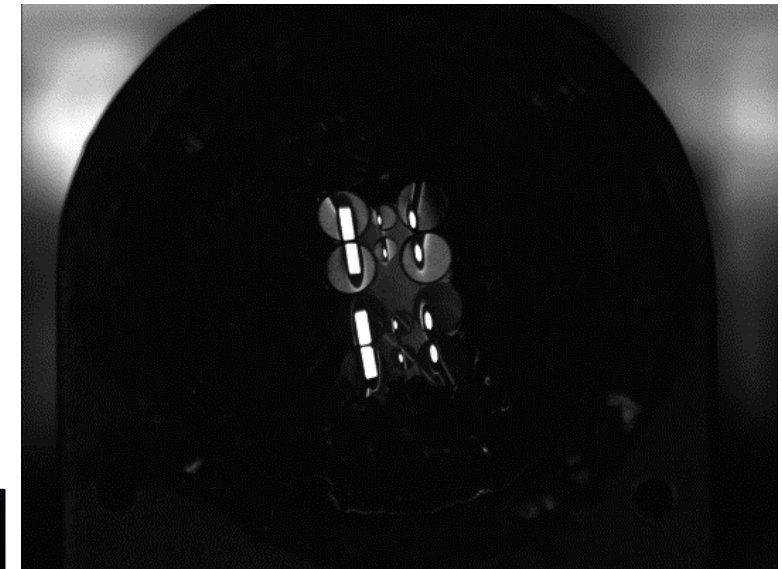
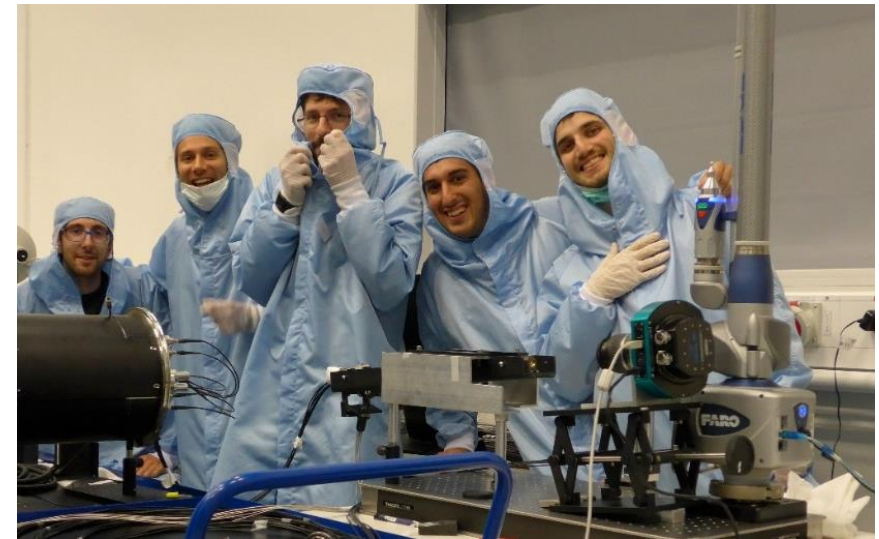
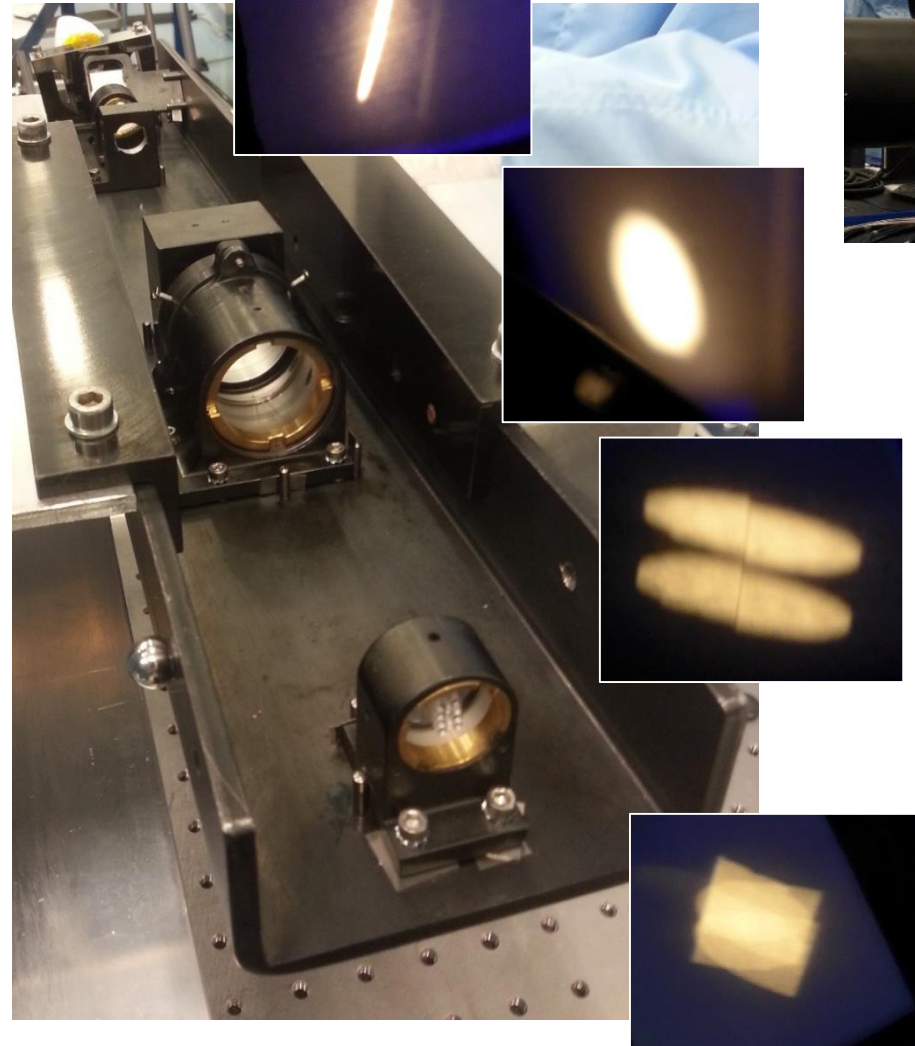
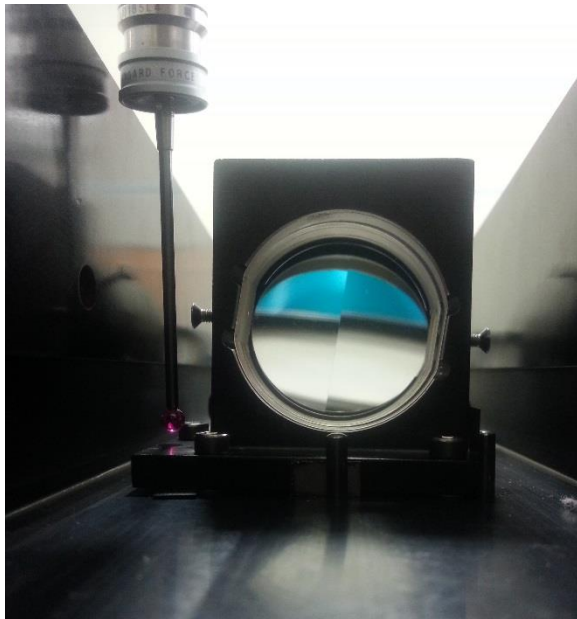
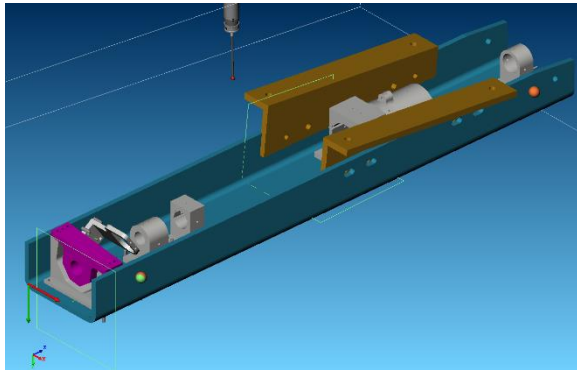


Protected Gold coating on SiO₂



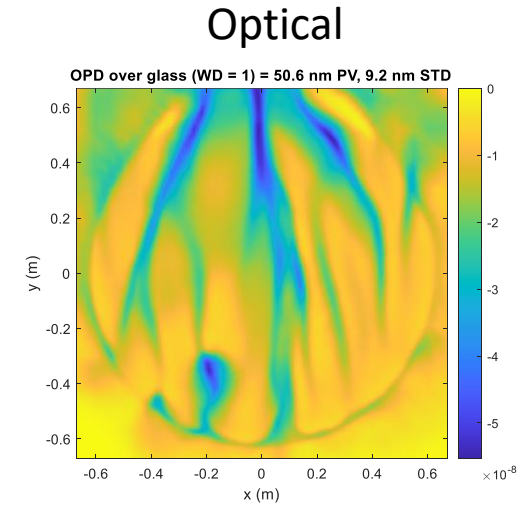
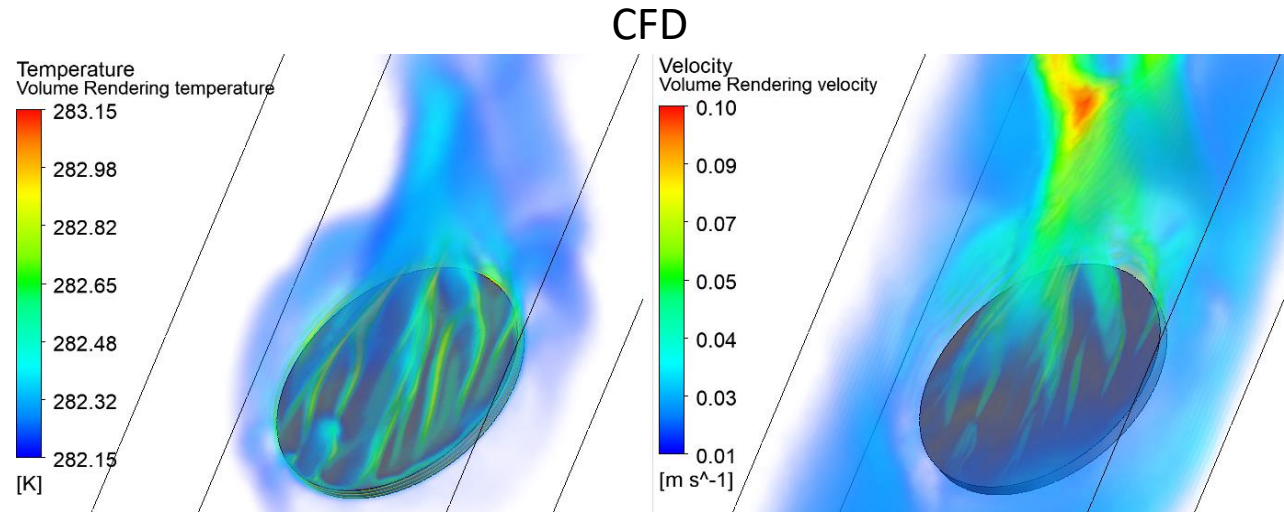
Anamorphic pupil slicer

Integration with CMM



Thermal analyses

ELT – MAORY as an example.



FEM



Mechanical



Optical

